

# Optical calibration of superconducting quantum sensors for particle detection

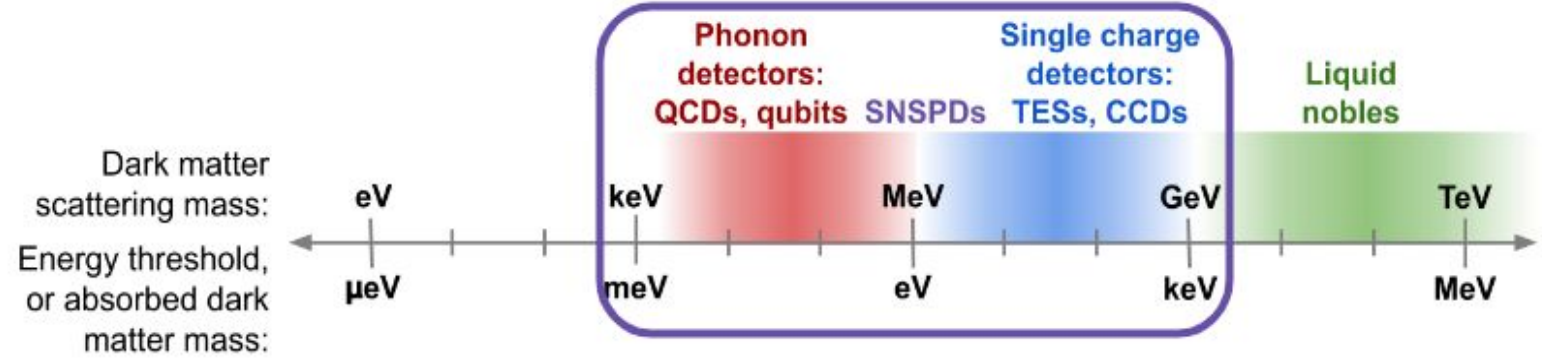
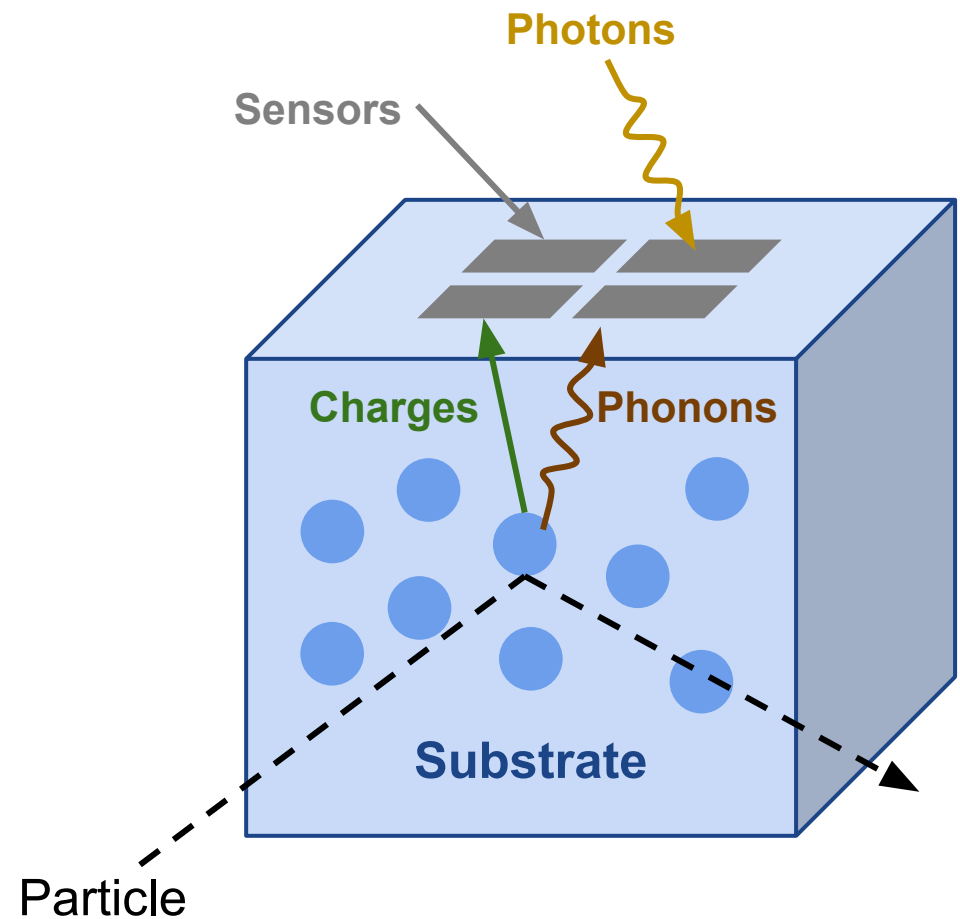
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Noshin Tabassum

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# Cryogenic sensors for particle detection:



**Detection of sub-GeV dark matter requires detectors sensitive to energy deposits of  $<1$  keV**

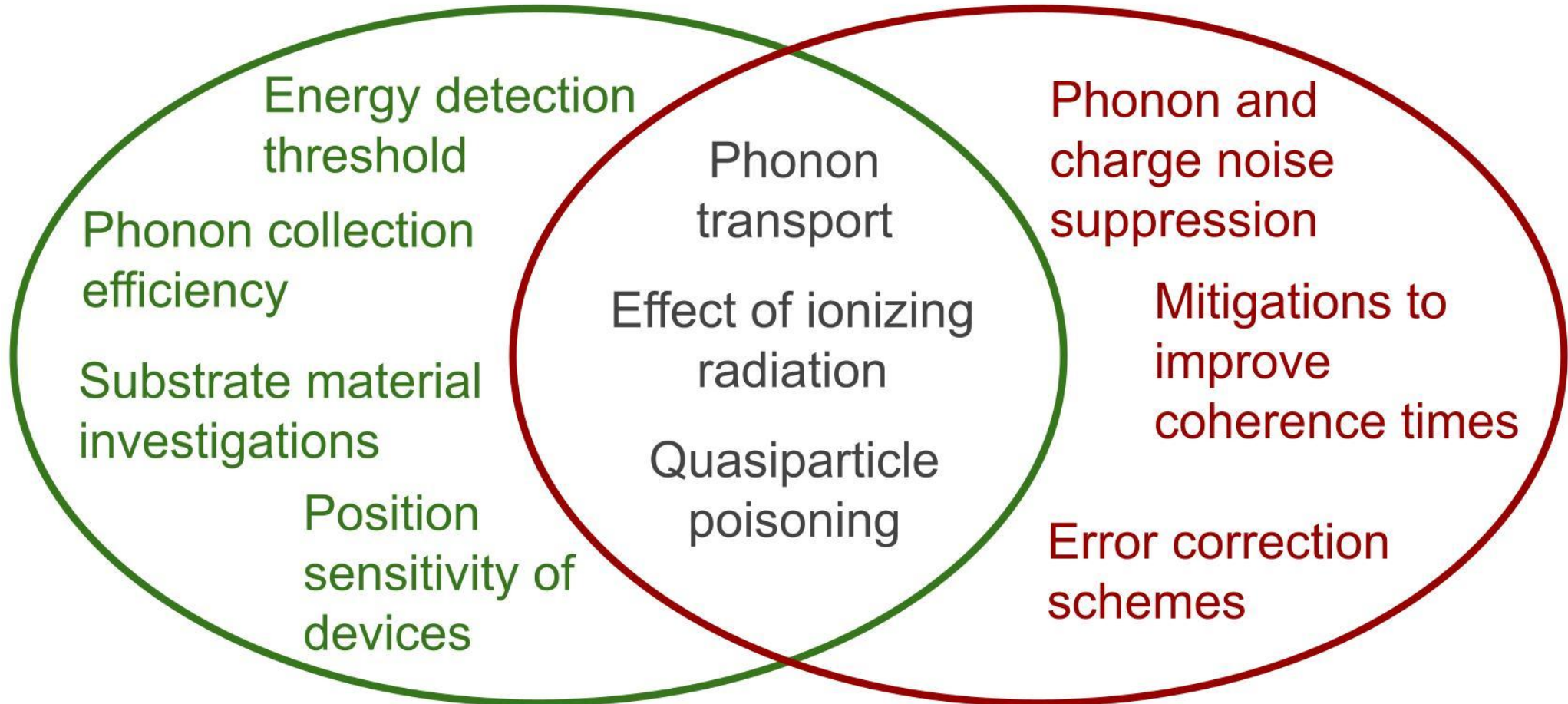
Novel calibration devices are required for the development and testing of these extremely sensitive detectors

# Technical challenges shared with QIS community

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## Dark matter sensors

## Superconducting qubits

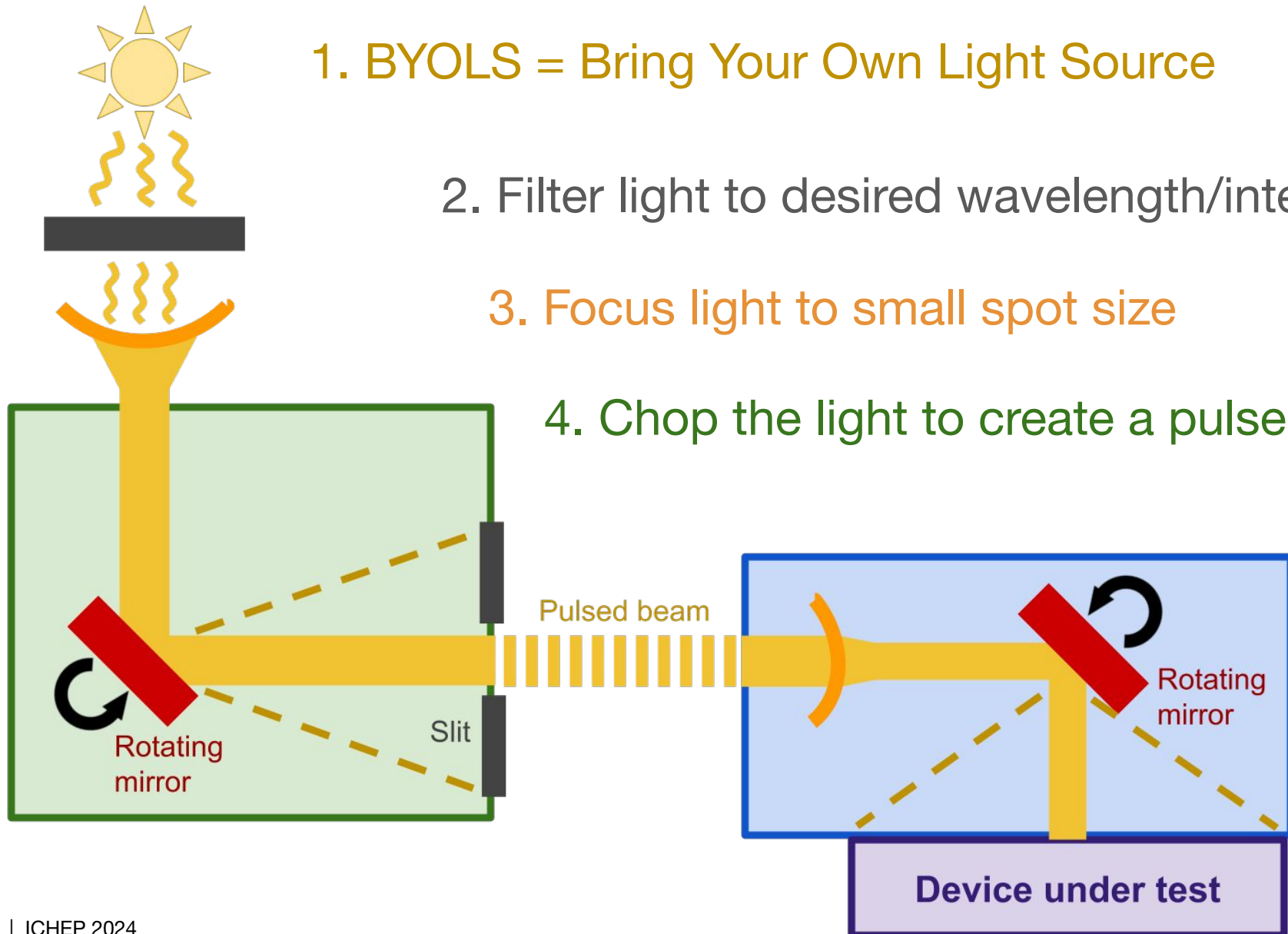


# Checklist for ideal calibration source:

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- ❑ **Works at range of low energies:** from O(eV) down to O(meV)
- ❑ **Time-resolved:**  $\sim\mu\text{s}$  pulsed operation for timing resolution
- ❑ **Position-dependent:** steerable over significant area of device
- ❑ **Spatially localized:** small beam spot ( $\sim 50\mu\text{m}$ ) to target small structures
- ❑ **Cryo-friendly:** functional at low temps ( $\sim 10\text{mK}$ ), low power dissipation
- ❑ **Device Independent**
- ❑ **Inexpensive**
- ❑ **No light leakage**

# Pulsed, steerable laser system for use with cryogenic devices:



5. Steer pulsed beam to desired location...

6. ...to produce energy deposits in your device

# Technical challenge:

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## Cryogenic movement

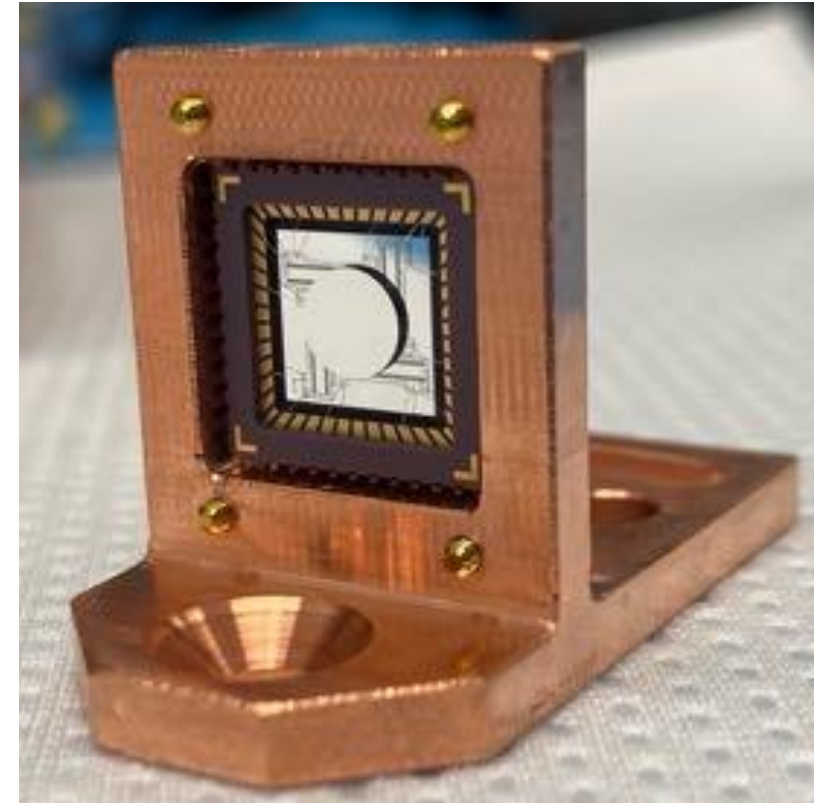
- Power dissipation
- Freeze out of movement mechanisms/control

## Our solution: modified MEMS mirrors (right)

- Al deposited over doped Si control lines for mK operation

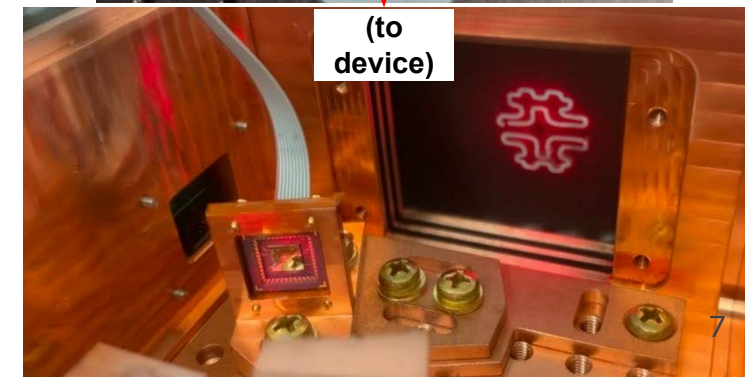
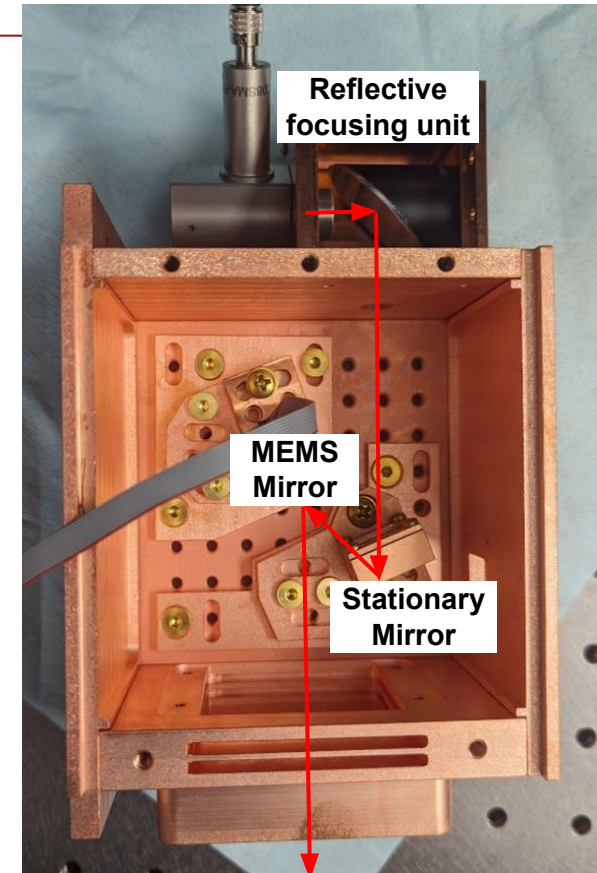
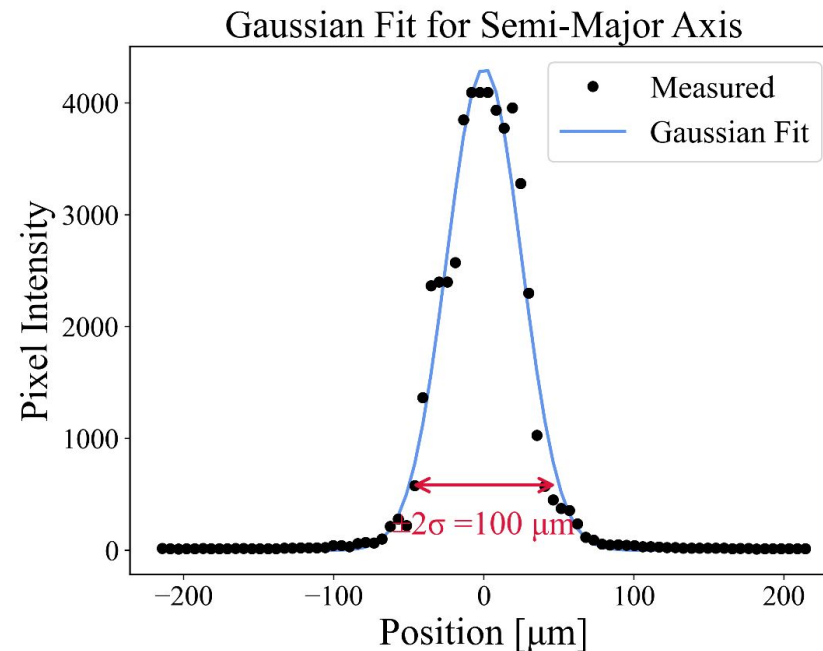
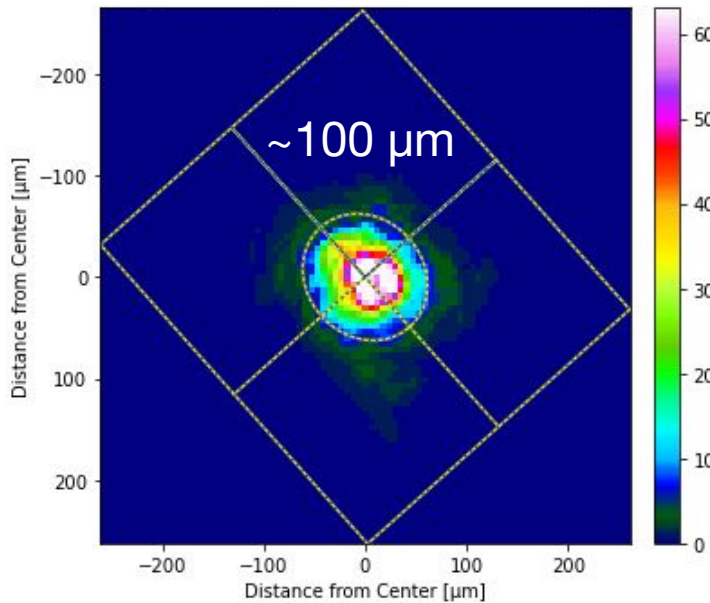
## Good because:

- High broadband reflectance
- Relatively large deflection angles ( $\sim 5^\circ$ )
- Limited power dissipation ( $\sim 1 \mu\text{W}$ )



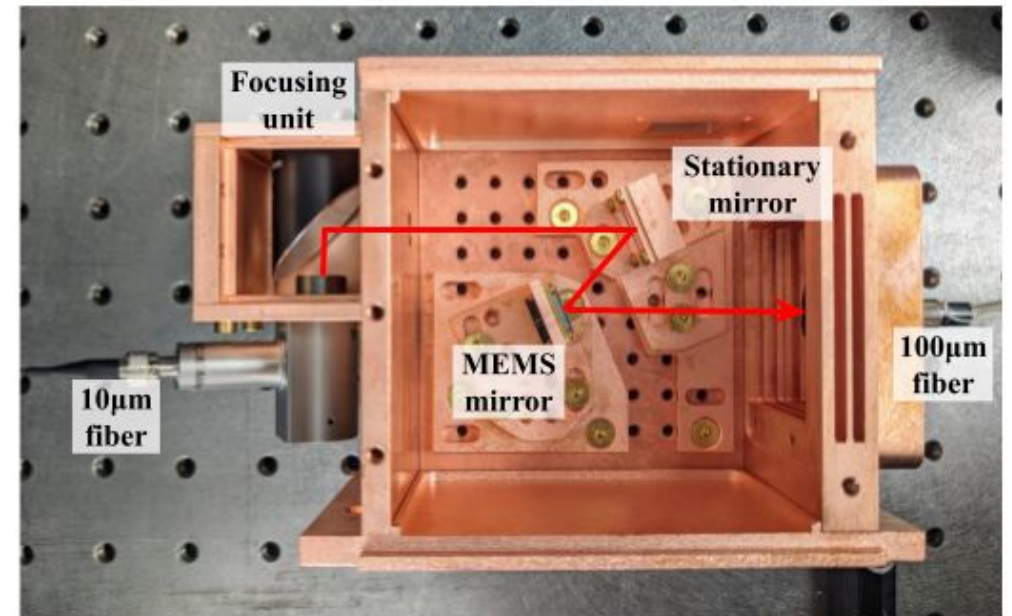
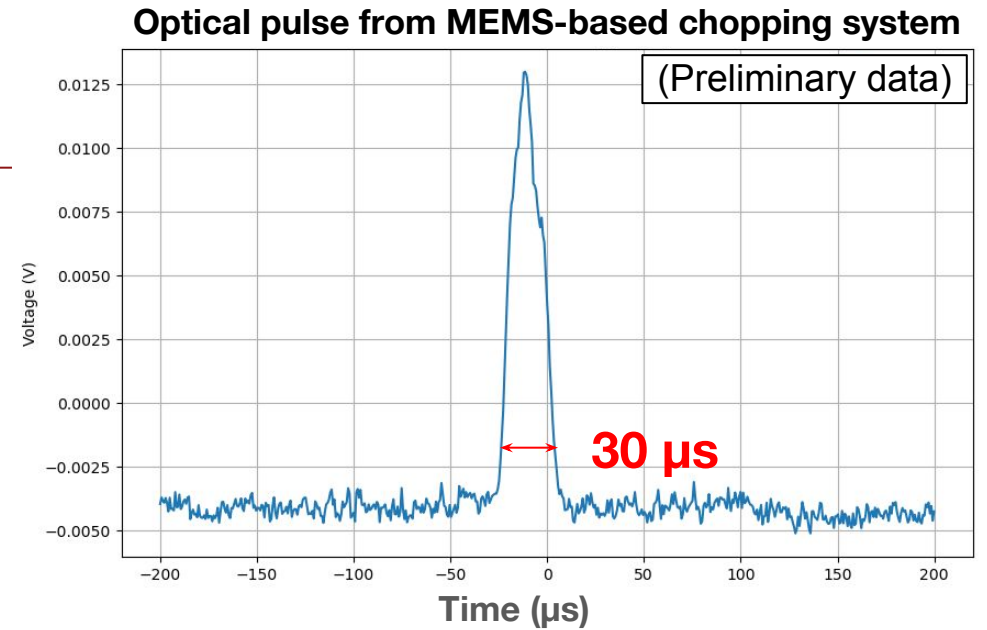
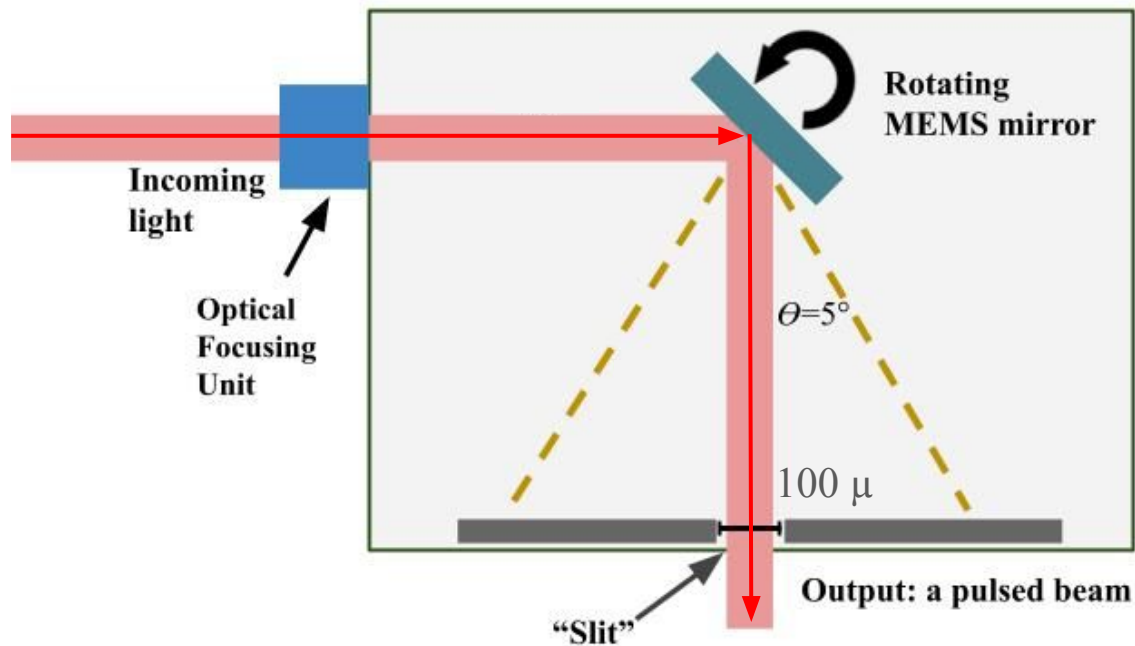
# Scanning unit design using MEMS mirror:

- Custom focusing unit that works over a range of wavelengths
- Spot size of  $\sim 100 \mu\text{m}$  that can scan over a  $\sim 3 \times 3 \text{ cm}$  area



# Broadband Optical Chopping

- Can generate  $\sim 10 - 30 \mu\text{s}$  pulses over the energy range of  $\sim 1.2 - 3 \text{ eV}$
- This will be used to distinguish calibration signals from backgrounds



[Paper in progress, Tabassum, N. et al.]



## Checklist for ideal calibration source:

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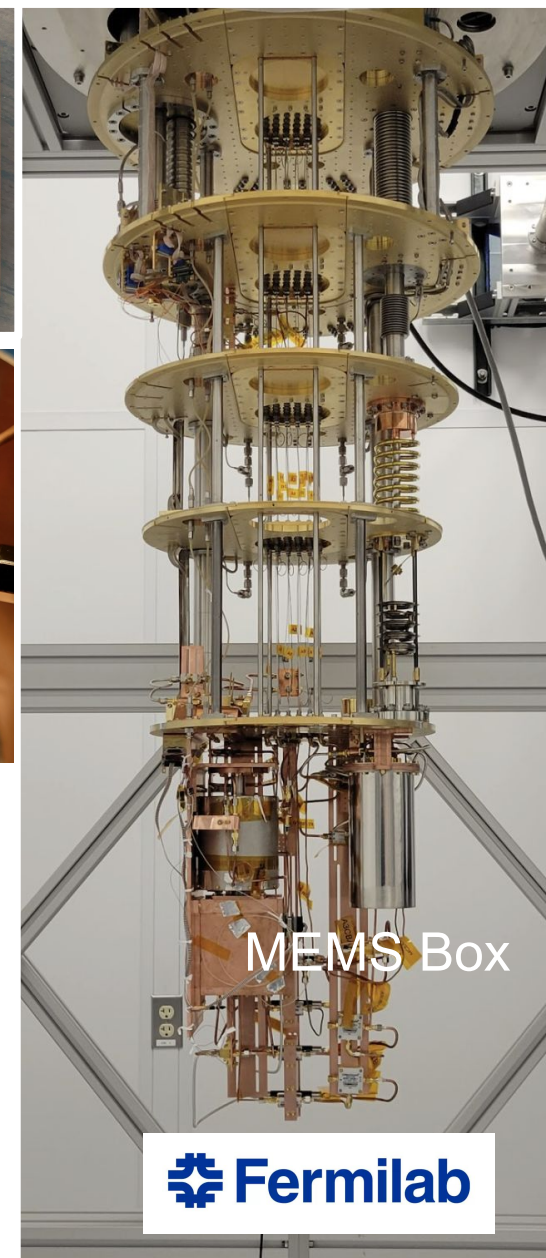
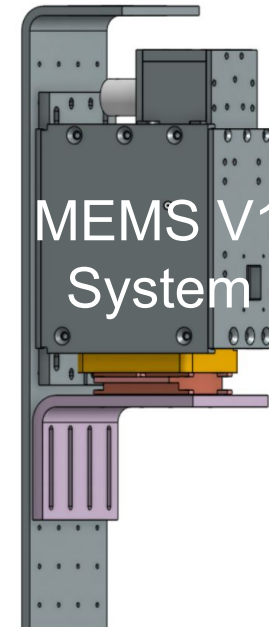
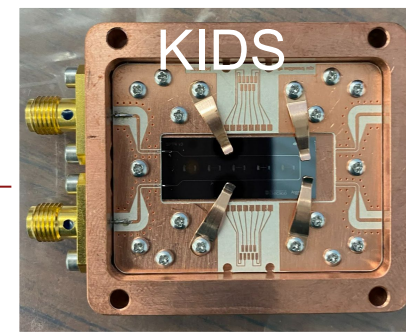
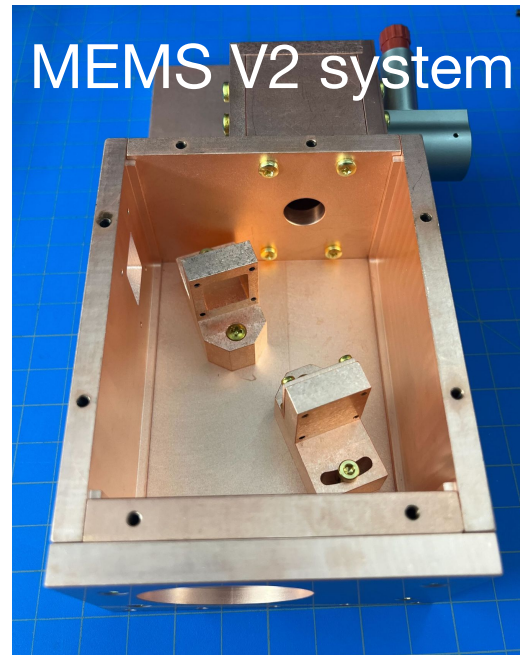
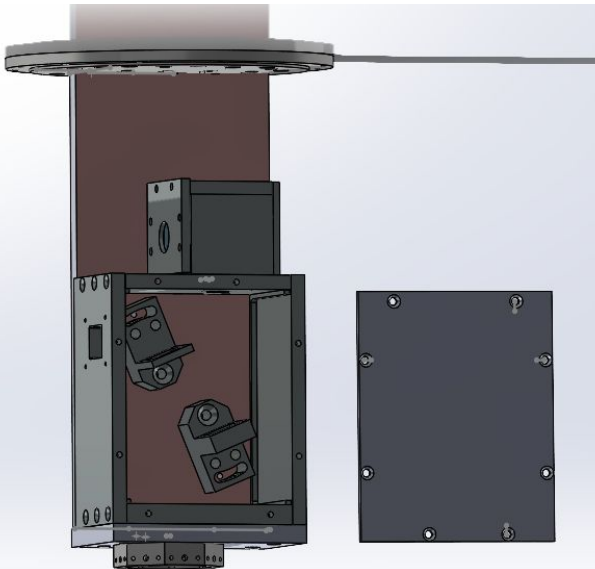
- ✓ **Works at range of low energies:** Mirrors rated to deliver 60 meV - 6 eV photons (further limited to ~1.2 - 3 eV by available optical fibers)
- ✓ **Time-resolved:** < 30  $\mu$ s pulsed operation for timing resolution
- ✓ **Position-dependent:** steerable over ~3 x 3 cm
- ✓ **Spatially localized:** small beam spot (<100  $\mu$ m) to target small structures
- ✓ **Cryo-friendly:** functional at low temps (~10 - 20 mK), low power dissipation (~1  $\mu$ W)
- ✓ **Device-independent:** deployed with multiple device types
- ✓ **Inexpensive:** ~\$10k
- ❑ **No light leakage:** will be investigated with TESs and KIDs

# Deployment in other QIS groups

Deploying systems at:

- Fermilab (KIDs, qubits on Si and sapphire)
- Syracuse (qubits, KIDs)
- UW - Madison (qubits, quantum dots)
- Livermore National Lab (KIDs, SNSPDs)

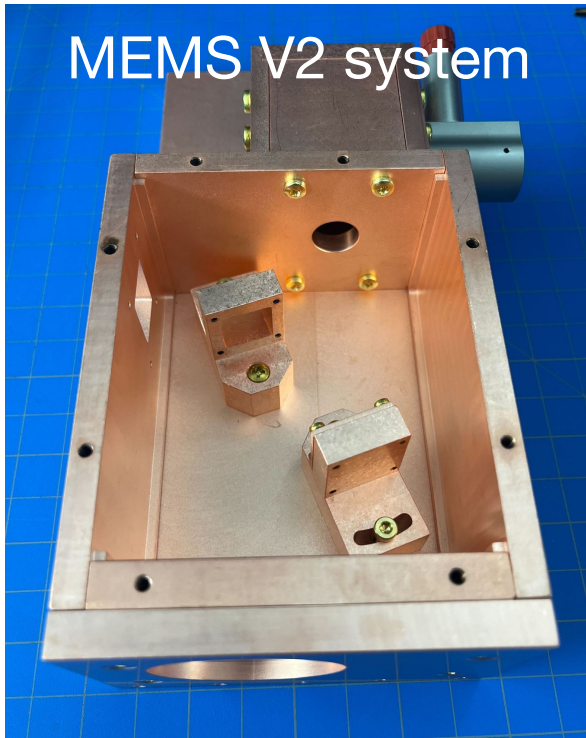
Version 2 housing allows for use of magnetic shield



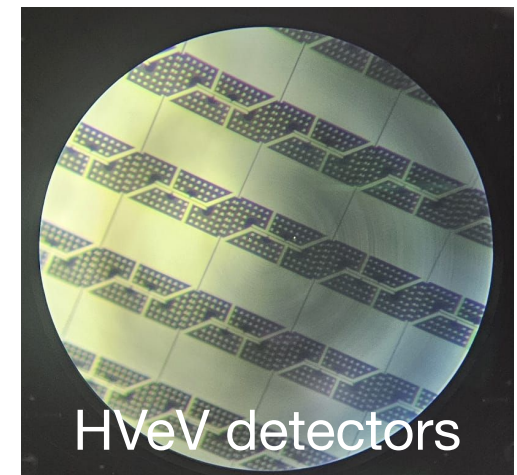
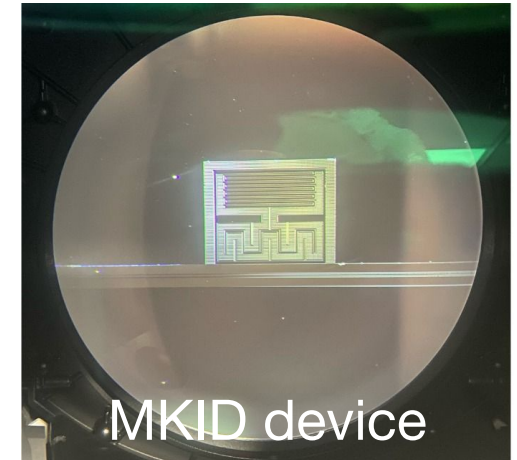
 Fermilab

[arXiv:2405.02258](https://arxiv.org/abs/2405.02258)

# Calibration of KID and HVeV detectors at SLAC



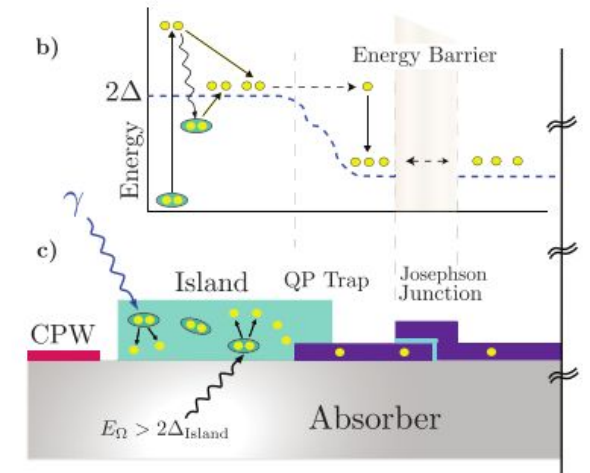
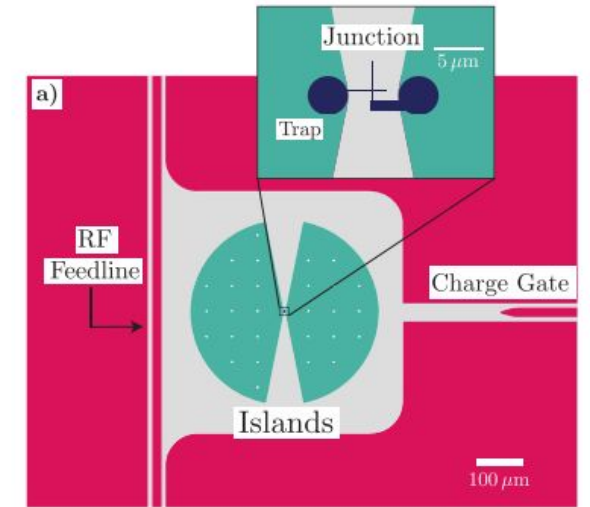
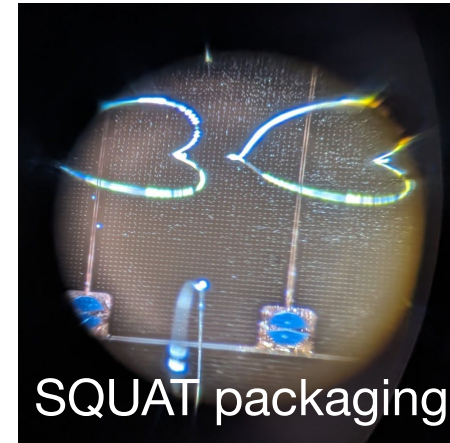
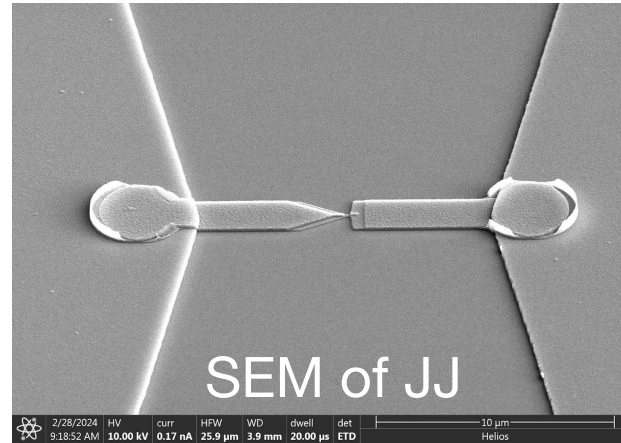
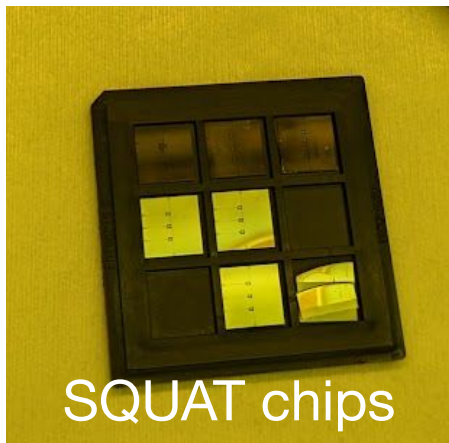
- Deploying the V2 MEMS calibration system with KIDs and TES-based HVeV detectors in the next 1-2 months
- This system will be used to investigate phonon transport, position sensitivity, and phonon loss mechanisms in the substrate of the detector



Top right: KID made of 50 nm AlMn on Si (credit: Zoe Smith)  
Bottom right: HVeV detector made of 600 nm Al/40nm W on Si (credit: Aviv Simchony)

# Calibration of SQUATs at SLAC

- Novel qubit-based sensors, Superconducting Quasiparticle Amplifying Transmons, designed to detect small amounts of deposited energy
- Can be used to probe dark matter with meV-scale recoils and axions in the THz photon regime
- Will be coupled to the MEMS V2 System

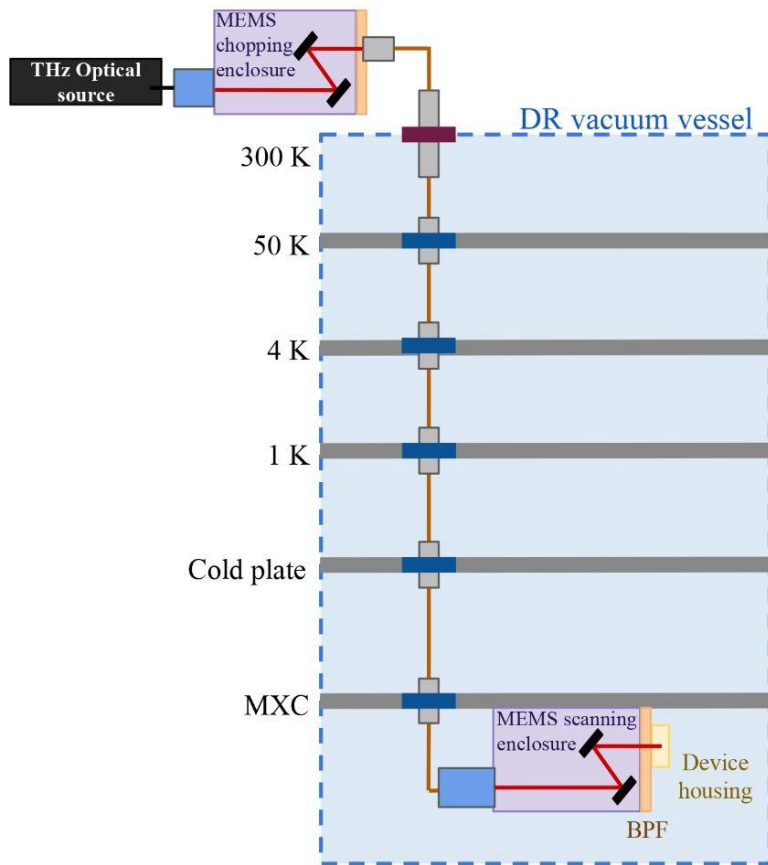


[arXiv:2310.01345](https://arxiv.org/abs/2310.01345)

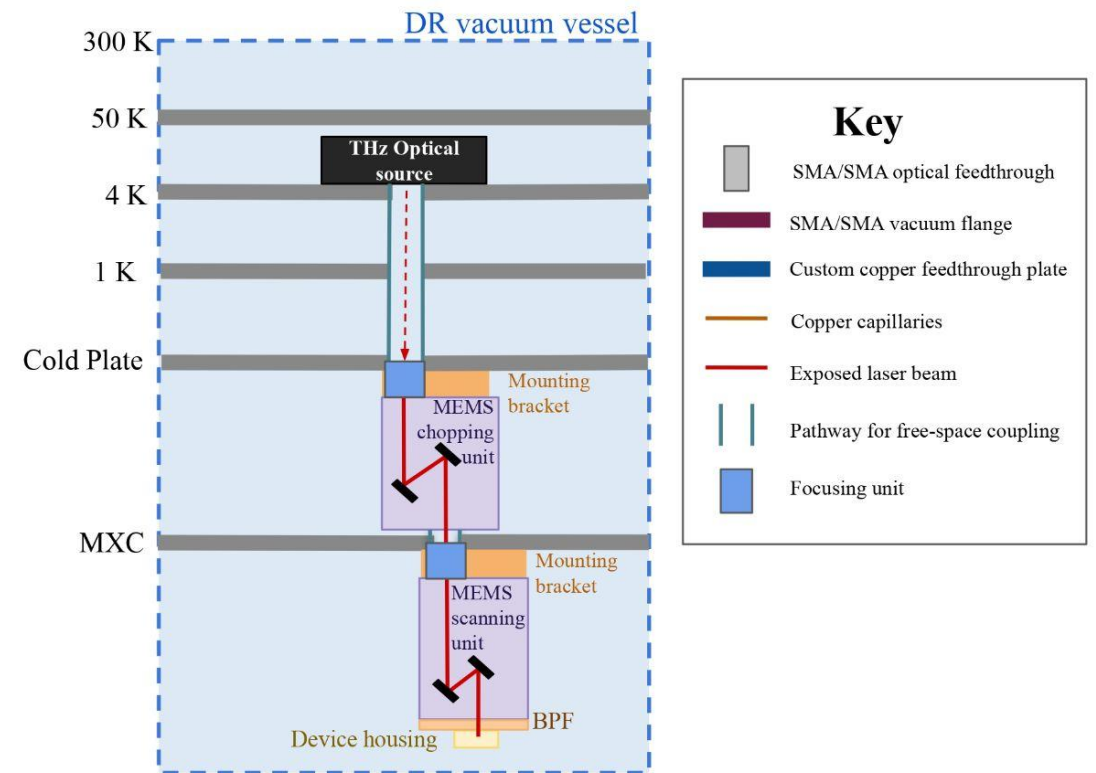
# Extending MEMS for THz calibrations

Two possible use cases:

## 1. Room-temperature THz source

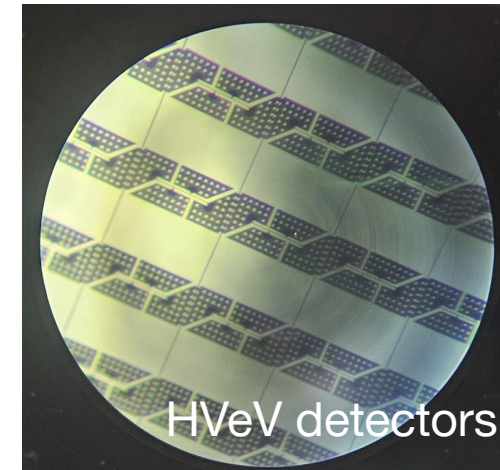
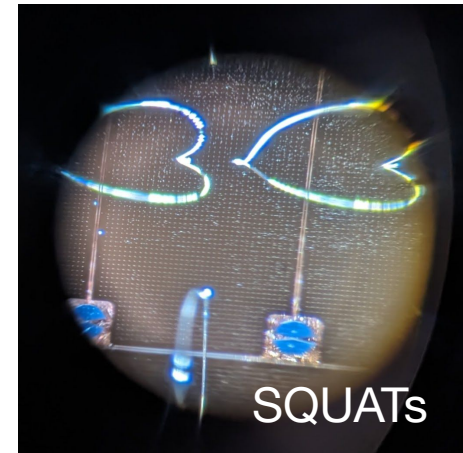
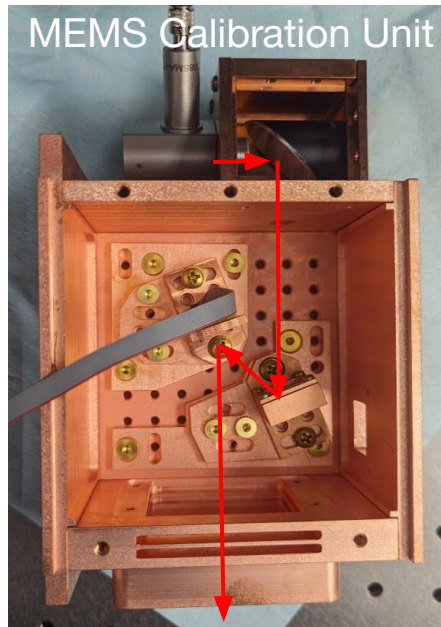
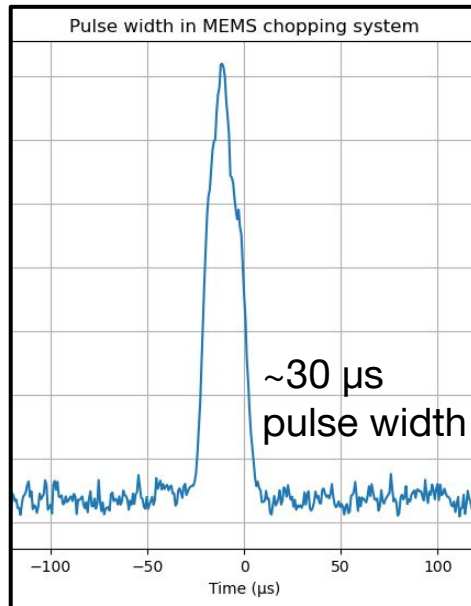
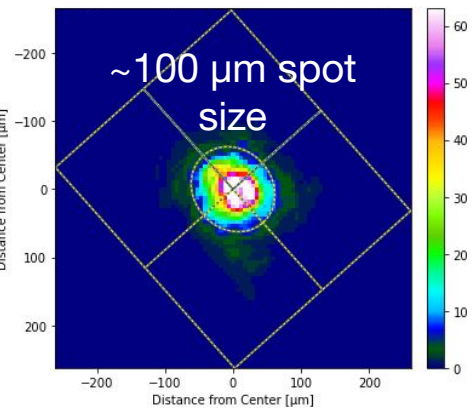
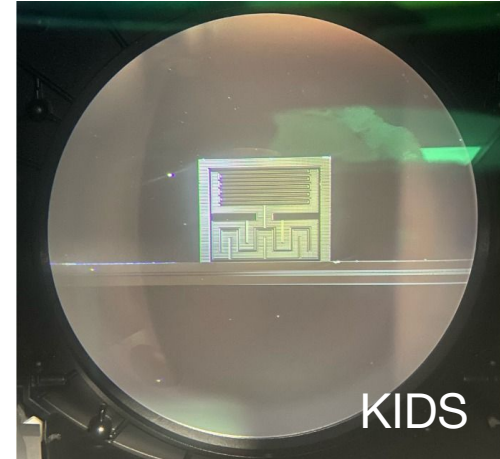


## 2. In-situ filtered blackbody source



# Conclusion

- Novel cryogenic detectors require low-energy calibrations
- Our MEMS mirror-based design can provide a pulsed, steerable beam in sub-eV regime with easily configurable intensity and pulse characteristics in a cryo-friendly way
- **Many impactful science topics to be explored**



## Calibration system team:

Noshin Tabassum (SLAC post-bac)

Kelly Stifter (SLAC Staff)

Hannah Magoon (Stanford grad)

Giana Perez (Stanford ugrad)

Noah Kurinsky (SLAC staff)



**Previously:** Anthony Nunez (Stanford ugrad), Sukie Kevane (Stanford ugrad), Haley Stueber (Stanford grad)

## SLAC DMQIS group:

Noah Kurinsky (Scientist)

Kelly Stifter (Scientist)

Betty Young (SC Faculty)

Nico Linton (Technician)

Jamie Ryan (Postdoc)

Chiara Salemi (Porat Fellow)

Taylor Aralis (Postdoc)

Jadyn Anczarski (Stanford grad)

Taj Dyson (Stanford grad)

Aviv Simchony (Stanford grad)

Zoe Smith (Stanford grad)

Hannah Magoon (Stanford grad)

Pam Stark (Stanford grad)

Noshin Tabassum (SLAC post-bac)

Giana Perez (Stanford ugrad)

